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# (54) CONNECTION METHOD AND SUBSTRATE

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## (57) ABSTRACT

A connection method includes the step of connecting, using a line on a dielectric element, two points through which a signal flows, the two points having different heights and the widths of the line at the positions of the two points having been adjusted on the basis of the thickness of the dielectric element.





















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CHARACTERISTIC IMPEDANCE	120.1	89.4	73.2	62.2	54.1	48.0	39.3
EFFECTIVE DIELECTRIC CONSTANT	1.93	1.99	2.03	2.07	2.10	2.12	2.16
CONDUCTOR WIDTH/ SUBSTRATE THICKNESS (W/d)	0.5	1.0	1.5	2.0	2.5	3.0	4 0
DIELECTRIC CONSTANT	2.55	2.55	2.55	2.55	2.55	2.55	2.55
CHARACTERISTIC	99.7	73.9	60.2	51.0	44.4	39.3	32.1
EFFECTIVE DIELECTRIC CONSTANT	2.80	2.92	3.00	3.07	3.12	3.17	3.25
CONDUCTOR WIDTH/ SUBSTRATE THICKNESS (W/d)	0.5	1.0	1.5	2.0	2.5	3.0	4.0
DIELECTRIC	4.00	4.00	4.00	4.00	4.00	4.00	4.00
CHARACTERISTIC	92.1	68.1	55.5	47,0	40.8	36.1	29.5
EFFECTIVE DIELECTRIC CONSTANT	3.28	3.43	3.53	3.62	3.69	3.75	3.85
CONDUCTOR WDTH/ SUBSTRATE THICKNESS (W/d)	0.5	0.1	t. R	5.0	2.5	3.0	4.0
DIELECTRIC	4.80	4.80	4.80	4.80	4.80	4.80	4.80

















CONDITIONS	SUBSTRATE A	SUBSTRATE B
SIGNAL LINE WIDTH	3.2 mm	3.2 mm
DIELECTRIC HEIGHT	1.6 mm	1.6 mm
CONDUCTOR HEIGHT	0.2 mm	0.2 mm
DIELECTRIC CONSTANT	Υ,	7.1
ELECTRIC LOSS(@10 GHz)	0.005	0.005
LINE LENGTH (A+B)	99	E
BOUNDARY CONDITION	OPEN STRUCTURE I BOUNDARY SURFACE (	N WHICH MODEL OF
ANALYSIS METHOD	TIME DOMAIN ANALYSIS U	ISING ELECTROMAGNETIC ATOR TOOL

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	З.	21 COMPONEN	S
ONNECTION MULEL	@3 GHz	@6 GHz	@10 GHz
RESENT INVENTION	-1.24 [dB]	-1.95 [dB]	-2.95 [dB]
THROUGH HOLE	-1.32 [dB]	-2.91 [dB]	-5.13 [dB]
WIRE BONDING	-2.91 [dB]	-5.89 [dB]	-9.26 [dB]

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![](_page_26_Figure_3.jpeg)

![](_page_27_Figure_3.jpeg)

![](_page_28_Figure_3.jpeg)

# CONNECTION METHOD AND SUBSTRATE

# BACKGROUND OF THE INVENTION

[0001] 1. Field of the Invention

**[0002]** The present invention relates to a connection method and a substrate. More particularly, the present invention relates to a connection method capable of reducing reflection due to impedance unmatching in a connection part and satisfactorily maintaining signal quality in a case where, for example, electronic parts are to be mounted on a substrate, and to a substrate for use therewith.

[0003] 2. Description of the Related Art

**[0004]** Connection structures between parts and substrates are broadly divided into the following two types. One type is a completely shielded structure like a coaxial cable, and the other type is an open structure in which inductive capacity exists between signal lines like wiring on a substrate.

**[0005]** Although the latter open structure is inferior to a coaxial structure from the viewpoint of crosstalk and electromagnetic interference, it is a practical structure which is advantageous in terms of industrial cost incurred for design, manufacture, and inspection, and in terms of connection properties, as can be understood when compared with ordinary printed wiring substrates.

**[0006]** However, in the shape of lines of an open structure, when handling a high-speed signal, deterioration of a transmission signal becomes a significant problem. In particular, as shown in FIG. 1, in a connection part between an electronic part that is surface mounted on a substrate and a substrate, a transmission signal is likely to be attenuated/deteriorated due to the influence of a reflected wave caused by impedance unmatching.

**[0007]** By forming wiring to be a line structure like a microstrip, it is possible to adjust impedance so as to deal with a high-speed signal. However, in the case of mounting between layers/substrates/parts having different heights, it is necessary to extend a terminal portion from the part side as shown in FIG. **2**, or it is necessary to form a viahole from a solder ball as shown in FIG. **3**, thereby being connected to the wiring on the substrate. Therefore, in a connection part between a part and a substrate shown in FIG. **1**, it is not possible to maintain a line structure through which impedance can be adjusted, and it is difficult to avoid deterioration of signal quality.

**[0008]** As a method of adjusting impedance in a connection part, a method disclosed in Japanese Unexamined Patent Application Publication No. 2000-216510 exists.

#### SUMMARY OF THE INVENTION

**[0009]** In the method disclosed in Japanese Unexamined Patent Application Publication No. 2000-216510, it is possible to reduce waveform distortion that is caused to occur in a transmission signal due to an inductance factor of a connector connected to a substrate. For that purpose, it is necessary to form a coaxial through hole in the periphery of a connection part.

**[0010]** As a consequence, for example, a structural arrangement problem makes it difficult to use this method for the end surface of a substrate, and a problem of space in high density wiring are likely to occur. Thus, it is difficult to cope with the recent technological trend toward higher wiring density and miniaturization of parts.

**[0011]** It is desirable to reduce reflection due to impedance unmatching in a connection part and to satisfactorily maintain signal quality in a case where, for example, electronic parts are to be mounted on a substrate on which a high-speed signal, such as a radio frequency (RF) signal is handled.

**[0012]** According to an embodiment of the present invention, there is provided a connection method including the step of connecting, using a line on a dielectric element, two points through which a signal flows, the two points having different heights and the widths of the line at the positions of the two points having been adjusted on the basis of the thickness of the dielectric element.

**[0013]** A higher point of the two points may be a point on a line of an electronic part mounted on a substrate, and a lower point of the two points may be a point on a line of the substrate.

**[0014]** An area along which the thickness of the dielectric element decreases toward a connection part with the line of the substrate may be formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights may be connected by a line disposed along the area.

**[0015]** Steps at which the thickness of the dielectric element decreases toward a connection part with a line of the substrate may be formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights may be connected by a line disposed on the steps.

**[0016]** According to another embodiment of the present invention, there is provided a substrate, wherein two points through which a signal flows, are connected using a line on a dielectric element, the two points having different heights and the widths of the line at the positions of the two points having been adjusted on the basis of the thickness of the dielectric element.

**[0017]** A higher point of the two points may be a point on a line of an electronic part mounted on a substrate, and a lower point of the two points may be a point on a line of the substrate.

**[0018]** An area along which the thickness of the dielectric element decreases toward a connection part with the line of the substrate may be formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights may be connected by a line disposed along the area.

**[0019]** Steps at which the thickness of the dielectric decreases toward a connection part with the line of the substrate may be formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights may be connected by a line disposed on the steps.

**[0020]** According to embodiments of the present invention, it is possible to reduce reflection due to impedance unmatching in a connection part and satisfactorily maintain signal quality in a case where, for example, electronic parts are to be mounted on a substrate.

#### BRIEF DESCRIPTION OF THE DRAWINGS

**[0021]** FIG. 1 shows a method for connecting an electronic part and a substrate according to the related art;

**[0022]** FIG. **2** shows the structure of a surface mount part according to the related art;

**[0023]** FIG. **3** shows another configuration of a surface mount part according to the related art;

**[0024]** FIG. **4** shows an example of the configuration including a substrate and a surface mount part that is connected by a connection method according to an embodiment of the present invention;

**[0025]** FIG. **5** is a sectional view of the structure shown in FIG. **4**;

**[0026]** FIG. **6** is a view when the structure shown in FIG. **4** is viewed from directly above;

**[0027]** FIG. **7** shows an image in which discontinuous changes in impedance can be eliminated;

**[0028]** FIG. **8** shows an example of a case in which a coplanar line is used as a line forming a connection part;

[0029] FIGS. 9A and 9B show a dotted-line portion of FIG. 8;

[0030] FIGS. 10A and 10B show a microstrip line;

**[0031]** FIG. **11** shows results of calculations of characteristic impedance in a case where a microstrip line structure is adopted;

**[0032]** FIG. **12** shows examples of lines forming a connection part between a substrate and an electronic part;

**[0033]** FIG. **13** shows another example of the configuration of the connection part;

**[0034]** FIG. **14** shows still another example of the configuration of the connection part;

[0035] FIGS. 15A, 15B, 15C, and 15D show examples of surface mount parts;

[0036] FIG. 16 shows a microstrip line model;

[0037] FIG. 17A is a front view of the model of FIG. 16;

[0038] FIG. 17B is a sectional view of the model of FIG. 16;

[0039] FIG. 18 shows a transmission simulation result;

**[0040]** FIG. **19** shows a model in which substrates having different heights are connected by the present connection method;

**[0041]** FIG. **20** shows a model in which substrates having different heights are connected using a through hole;

**[0042]** FIG. **21** shows a model in which substrates having different heights are connected using wire bonding;

[0043] FIG. 22 is a view showing conditions for a model;

**[0044]** FIG. **23** is another view showing conditions for a model;

[0045] FIG. 24 shows simulation results;

[0046] FIG. 25 shows S21 components at each of frequencies 3 GHz, 6 GHz, and 10 GHz;

[0047] FIGS. 26A and 26B show an example of the shape of a line on an electronic part side;

**[0048]** FIGS. **27**A and **27**B show another example of the shape of the line on the electronic part side;

**[0049]** FIGS. **28**A and **28**B show still another example of the shape of the line on the electronic part side;

**[0050]** FIGS. **29**A and **29**B show an example of the shape of the line on the electronic part side;

**[0051]** FIGS. **30**A and **30**B show another example of the shape of the line on the electronic part side;

**[0052]** FIG. **31** is a perspective view showing an example of connection in a case where the number of dielectric layers of an electronic part is two;

**[0053]** FIG. **32** is a sectional view of the structure shown in FIG. **31**; and

**[0054]** FIG. **33** is a perspective view showing an example of a case in which the present connection method is used for connection of a semiconductor package.

#### DESCRIPTION OF THE PREFERRED EMBODIMENTS

**[0055]** FIG. **4** is a perspective view showing an example of the configuration including a substrate **1** and a surface mount part **2**, which are connected by a connection method according to an embodiment of the present invention. FIG. **5** is a sectional view showing the structure shown in FIG. **4**. FIG. **6** is a front view when the structure shown in FIG. **4** is viewed from directly above.

[0056] In general, in order to mount a part on a printed wiring substrate, a method in which a metal extension is connected to a device so as to make an electrical connection is adopted (see FIGS. 1 and 2). As is shown in such a manner as to be enclosed using a dotted line in FIG. 4, the connection part between the substrate 1 and the surface mount part 2, which are connected by this connection method, is formed in such a manner that a terminal end part that is extended as is kept to be a line shape from the top surface (the surface in parallel with the surface of the substrate 1) of the surface mount part 2 is connected to a line 1A disposed on the substrate 1.

**[0057]** The feature of this connection method lies in that, as shown in such a manner as to be enclosed using a dotted line of FIG. 5, by forming a dielectric end 2A of the surface mount part 2 so as to be a slope, the substrate 1 and the surface mount part 2 are connected to each other while a metal transmission line disposed in a dielectric element along the slope is made to gradually approach the substrate 1. In this example, the surface mount part 2 has a shape such that the cross section thereof in the vertical direction is a trapezoid.

**[0058]** At this time, the line width of a microstrip line on the side of the surface mount part **2** is adjusted by the characteristic impedance determined from electrical characteristics thereof and the geometric shape thereof. As shown in FIGS. **4** and **6**, in this example, the nearer to the substrate **1**, that is, the smaller the height of a position relative to the substrate **1** used as a reference and the smaller the thickness of the dielectric element of the slope on which the surface mount part **2** is mounted, the smaller the line width. In the example of FIGS. **4** and **6**, the width in the connection part between the line disposed in the dielectric end **2**A and the line **1**A on the substrate **1** is the same as the width of the line **1**A.

**[0059]** As described above, by gradually changing the line width and the dielectric thickness, it is possible to connect the substrate 1 to the surface mount part 2 while the characteristic impedance of the connection part is adjusted. Thus, it is possible to eliminate discontinuous changes of characteristic impedance in the connection part and reduce reflection components. An image of capable of eliminating discontinuous changes of characteristic impedance in the connection part and reduce reflection part and reducing reflection components is shown in FIG. 7. In the figure that shows an image of unmatching of characteristic impedance in the upper area of FIG. 7, the recessed portion shows characteristic impedance of a portion (portion floating in air), which is not in contact with the electronic part or the substrate, of the terminal shown in FIGS. 1, 2 and 3, through which the electronic part is connected to the substrate.

**[0060]** It is in general that, as shown in FIGS. **10**A and **10**B, if the width (line width) of the conductor material is denoted as W and the dielectric thickness is denoted as d, the charac-

teristic impedance in the microstrip line is determined on the basis of Expressions (1A), (1B), (2A), and (2B) described below.

When 
$$\frac{W}{d} < 1.0, Z_0 = \frac{60}{\sqrt{\varepsilon_e}} \cdot \ln\left(\frac{8d}{W} + \frac{W}{4d}\right)$$
 (1A)

$$\varepsilon_e = \frac{\varepsilon_r + 1}{2} + \frac{\varepsilon_r - 1}{2} \cdot \left( \frac{1}{\sqrt{1 + \frac{12d}{W}}} + 0.04 \left(1 - \frac{W}{d}\right)^2 \right)$$
(1B)

When 
$$\frac{W}{d} \ge 1.0$$
,  $Z_0 = \frac{120\pi}{\sqrt{\varepsilon_e}} \cdot \left( \frac{\frac{W}{d} + 1.393 + 0.667}{\ln\left(\frac{W}{d} + 1.444\right)^{-1}} \right)^{-1}$  (2A)

$$\varepsilon_e = \frac{\varepsilon_r + 1}{2} + \frac{\varepsilon_r - 1}{2} \cdot \frac{1}{\sqrt{1 + \frac{12d}{W}}}$$
(2B)

where  $Z_0$  is the characteristic impedance,  $\in_e$  is the effective dielectric constant,  $\epsilon_r$  is the relative dielectric constant, W is the line width, and d is the dielectric thickness.

**[0061]** The calculation result of the characteristic impedance in a case where a microstrip line structure is adopted is shown in FIG. **11**.

**[0062]** In addition, also, regarding typical line shapes shown in FIG. **12**, a general expression for determining characteristic impedance on the basis of the electric characteristic value and a cross-sectional shape of a line exists. FIG. **12** shows, as lines forming a connection part between a substrate and an electronic part, a strip line, a microstrip line, a strip line, a coplanar line, and a parallel line.

[0063] FIG. 8 shows an example of a case in which a coplanar line is used as a line forming a connection part between the substrate 1 and the surface mount part 2. As described above, as a line forming a connection part in this manner, a coplanar line can be used. FIG. 9A is a sectional view showing a portion enclosed using a dotted line in FIG. 8. FIG. 9B is a front view showing the top surface of an electronic part of FIG. 8. In the example of FIG. 8, the closer the line disposed on the slope to the connection part with the substrate, the larger the width of the line.

**[0064]** As the constituent material of the substrate 1, a common substrate material is used. For the conductor part, a metal conductor such as, for example, copper, is used. For the dielectric part, for example, phenol, a glass epoxy resin, alumina, or Teflon (registered trademark) is used.

**[0065]** The above-described connection method can be applied to a case in which the entirety of electronic parts, such as an antenna and an LSI, which are surface mounted on a substrate, is connected onto the substrate. Hereinafter, a connection method in which, in the manner described above, at least a part of the side surface of a dielectric element forming the surface mount part **2** is formed as a slope, and a conductor is wired along the slope, thereby connecting the electronic part to the wiring on the substrate will be referred to simply as the present connection method as appropriate.

**[0066]** With the present connection method, in a case where electronic parts, such as an antenna and a filter circuit, are to be surface mounted onto a substrate that handles a high-speed signal, such as a radio frequency (RF) signal, it becomes possible to reduce reflection due to impedance unmatching in

the connection part and to satisfactorily maintain signal quality. The high-speed signal herein refers to a signal having a connection length or a wiring length that exceeds  $\frac{1}{10}$  of the wavelength of the transmission signal at the maximum frequency.

#### **MODIFICATION**

**[0067]** As described with reference to FIG. **12**, the structure of the connection line can be handled as a distributed constant circuit. The connection line may be a microstrip line, a strip line, a coplanar line, or a parallel line as long as impedance can be adjusted.

**[0068]** The physical shape of the line width of the connection part may be discontinuous as long as impedance is continuously changed in an electrical manner. When the line width of the connection part is to be determined, a rate of change in the impedance at the line length with respect to the wavelength of the transmission frequency becomes a measure.

[0069] The connection part may be configured in such a manner that, even though the entire dielectric end 2A forming the side surface of the surface mount part 2 as shown in FIG. 4 is not obliquely provided, a part of the side surface thereof may be formed so as to be a slope as shown in FIG. 13, and the line whose width has been adjusted may be wired on the slope. Alternatively, a through hole may be obliquely provided in the end surface as shown in FIG. 14, and a line whose width has been adjusted may be wired in the inner side thereof.

**[0070]** For the surface mount part **2** that can be connected by the present connection method, in addition to an antenna circuit, various parts, such as a filter circuit, a resonance circuit, a mixer circuit, and a splitter circuit, shown in FIGS. **15**A to **15**D, can be used.

**[0071]** Furthermore, the present connection method can be applied to not only the connection between a printed wiring substrate and a surface mount part, but also to wiring between parts, wiring between substrates, wiring inside parts, wiring of a multilayered substrate, and semiconductor wiring. For example, it is considered that the present connection method is effective for wiring inside a multilayered substrate or parts, or effective for wiring connection inside a semiconductor package.

**[0072]** With the adoption of the present connection method, **[0073]** 1. signal deterioration due to impedance unmatching between wires can be reduced. In particular, the present connection method is effective for a connection between substrates, which handle a high-speed signal, such as in the case of an RF circuit, and parts.

**[0074]** 2. the present connection method can be realized using a simple line structure, such as a microstrip line or a coplanar line, and an extra circuit, a connector, and the like are not necessary.

**[0075]** 3. the present connection method can be applied to not only surface mount parts, such as a filter and an antenna, but also to overall parts (wiring inside a multilayered substrate, a semiconductor package, or the like) in which an inductive capacity exists between signal lines.

#### SUPPLEMENTAL DESCRIPTION

**[0076]** In order to supplement the above point **1**, a description will be given below of a result in which deterioration in a transmission signal is analyzed by electromagnetic simulation.

[0077] A simple microstrip line model is shown in FIG. 16 and FIGS. 17A and 17B. FIG. 16 shows a model in a threedimensional manner. FIG. 17A is a front view of the model of FIG. 16, and FIG. 17B is a sectional view of the model of FIG. 16.

**[0078]** This model is formed by a signal line, a dielectric substrate, and a GND (formed in such a manner that a signal line is disposed on a substrate formed of a GND layer and a dielectric layer). In order to simulate deterioration of a transmission signal, a test signal is input from an input port, and the transmitted signal is observed at an output port. For evaluation, a general value in which an S-parameter is represented in dB (decibel) is generally used. Therefore, here, an S-parameter represented by the following Expression (3) is used as S21.

S21=log 10(output signal/input signal) [dB] (3)

**[0079]** The transmission simulation result is shown in FIG. **18**. The horizontal axis of FIG. **18** shows the frequency [GHz], and the vertical axis shows S21 [dB]. As the frequency increases, S21 is slightly decreased. Since the material of the line model is homogenous and the shape of the cross section thereof is fixed, the deterioration is considered to be mainly caused by induced loss of a signal that is transmitted through the substrate. Therefore, in this model in a state close to an ideal state in which impedance matching has been achieved, transmission deterioration is approximately –1 dB@10 GHz.

**[0080]** Next, a description will be given below of simulation results in which a typical connection method and the present connection method are used.

**[0081]** FIG. **19** shows a model in which substrates having different heights are connected to each other using the present connection method.

[0082] FIGS. 20 and 21 each show a model in which substrates having different heights are connected to each other by using a through hole and wire bonding, respectively. FIGS. 22 and 23 show conditions of models shown in FIGS. 19, 20 and 21.

**[0083]** The models shown in FIGS. **19**, **20** and **21** are such that the section between a position  $P_1$  in a signal line A of a substrate A and a position  $P_2$  in a signal line B of a substrate B arranged so as to overlap the substrate A (dielectric element A), which is indicated by being enclosed using a dotted line in FIG. **22**, are connected by the present connection method, a through hole, and wire bonding, respectively.

**[0084]** The conditions of the substrate A configured in such a manner that the dielectric element A is laminated on the GND surface A and the signal line A is disposed on the input side on the dielectric element A, and the substrate B configured in such a manner that the dielectric element B is laminated on the GND surface B and the signal line B is disposed on the dielectric element B are shown in FIG. **23**.

**[0085]** In the conditions of FIG. **23**, the line widths of the signal lines A and B are set to 3.2 mm, the height is set to 0.2 mm, and the total of the line lengths of the signal lines A and B is set to 30 mm. The height of the dielectric elements A and B is set to 1.6 mm, the dielectric constant is set to  $7.1 \times 10^{-12}$  [F/m], and the induced loss when a signal of 10 GHz is made to flow is set to 0.005.

**[0086]** The results of simulation performed by each connection method under the conditions shown in FIG. **23** are shown in FIG. **24**. The horizontal axis of FIG. **24** indicates the frequency [GHz], and the vertical axis indicates S21 [dB].

The values of S21 [dB] at each frequency of 3 GHz, 6 GHz, and 10 GHz are shown in FIG. 25.

**[0087]** It can be seen from the results shown in FIGS. **24** and **25** that the deterioration of the transmission signal of the present connection method is the smallest among the three models. Furthermore, the simulation result of the model in which the present connection method is used is closest to the simulation result of the ideal model shown in FIG. **18**. It can be seen that, in particular, as the frequency becomes higher, the more apparent the difference in the characteristics between the present connection method and the other methods. It is considered from these results that use of the present connection method is effective for reducing signal deterioration.

Example of Connection Between Line on Electronic Part Side and Line on Substrate Side

**[0088]** Next, a description will be given below of the shape of a line on an electronic part side in the vicinity of a connection part with a line on a substrate side.

[0089] FIG. 26A is a front view showing a first shape. FIG. 26B is a sectional view of the structure shown in FIG. 26A. [0090] The first shape shown in FIGS. 26A and 26B is the same as that described with reference to FIGS. 4 to 6. That is, as shown in FIG. 26B, a slope is formed in the end portion of an electronic part, and a line 21B, which is a part of a line on the electronic part side, is disposed along the slope. The thickness of the dielectric element 22 on the electronic part side at each position of the line 21B decreases linearly as the line approaches the connection part with the line 11 on the substrate side.

**[0091]** The shape when the line **21**B is viewed from directly above is, as shown in FIG. **26**A, formed so as to be symmetrical about the axis in the length direction of the line **21**B, and the width is changed linearly between a width  $W_2$  and a width  $W_1$  according to the thickness of the dielectric element **22** at each position. The width  $W_1$  is the width of the line **21**A disposed on the top surface of the dielectric element **22** on the electronic part side, and the width  $W_2$  is the width of the line **11**A disposed in the dielectric element **12** on the substrate side.

[0092] FIG. 27A is a front view showing a second shape. FIG. 27B is a sectional view of the structure shown in FIG. 27A.

[0093] In the example of this shape, as shown in FIG. 27B, five steps are formed in the end portion of the electronic part, and the line 21B, which is a part of a line on the electronic part side, is disposed on these steps. The thickness of the dielectric element 22 on the electronic part side at each position of the line 21B decreases in a step-like manner as the line approaches the connection part with the line 11 on the substrate side and as the number of steps from the substrate decreases.

**[0094]** The shape when the line **21**B is viewed from directly above is, as shown in FIG. **27**A, formed symmetrical about the axis of the line **21**B in the length direction, and the width is changed in a step-like manner from the width  $W_2$  to the width  $W_1$  according to the thickness of the dielectric element **22** at each position.

[0095] FIG. 28A is a front view showing a third shape. FIG. 28B is a sectional view of the structure shown in FIG. 28A.

**[0096]** In the example of this shape, as shown in FIG. **28**B, a curved surface whose cross section is formed nearly in a fan shape is formed in the end portion of the electronic part. The

line **21**B, which is a part of the line on the electronic part side, is disposed along this curved surface. The thickness of the dielectric element **22** on the electronic part side at each position of the line **21**B decreases as the line approaches the connection part with the line **11** on the substrate side.

[0097] The shape when the line 21B is viewed from directly above is, as shown in FIG. 28A, formed in a shape symmetrical about the axis of the line 21B in the length direction, and the width is changed at a predetermined ratio between a width  $W_2$  and a width  $W_1$ .

[0098] FIG. 29A is a front view showing a fourth shape. FIG. 29B is a sectional view of the structure shown in FIG. 29A.

**[0099]** The shape shown in FIG. **29**A is the same as the shape described with reference to FIG. **26**A. The line **21**B is formed in a shape symmetrical about the axis of the line **21**B in the length direction, and the width is changed linearly between a width  $W_2$  and a width  $W_1$  according to the thickness of the dielectric element **22** at each position.

**[0100]** The shape shown in FIG. **29**B is the same as the shape described with reference to FIG. **27**B. Five steps are formed in the end portion of an electronic part, and the line **21**B, which is a part of the line on the electronic part side, is disposed on these steps. The thickness of the dielectric element **22** on the electronic part side at each position of the line **21**B decreases in a step-like manner as the line approaches the connection part with the line **11** on the substrate side and as the number of steps from the substrate decreases.

**[0101]** FIG. **30**A is a front view showing a fifth shape. FIG. **30**B is a sectional view of the structure shown in FIG. **30**A. **[0102]** The shape shown in FIG. **30**A is the same as the shape described with reference to FIG. **27**A. The line **21**B is formed in a shape symmetrical about the axis of the line **21**B in the length direction, and the width thereof is changed in a step-like manner between a width  $W_2$  and a width  $W_1$  according to the thickness of the dielectric element **22** at each position.

**[0103]** The shape shown in FIG. **30**B is the same as the shape described with reference to FIG. **26**B. A slope is formed in the end portion of the electronic part, and the line **21**B, which is a part of the line on the electronic part side, is disposed along the slope. The thickness of the dielectric element **22** on the electronic part side at each position of the line **21**B decreases linearly as the line approaches the connection part with the line **11** on the substrate side.

#### APPLICATION EXAMPLE

**[0104]** In the foregoing, a case in which the number of dielectric layers of the electronic part is one has been described. Even in a case where the dielectric layer is multi-layered, in a similar manner, it is possible to connect a line on the electronic part to a line on the substrate.

**[0105]** FIG. **31** is a perspective view showing an example of connection in a case where the number of dielectric layers of the electronic part is two. The same components as those shown in FIG. **26** are designated with the same reference numerals.

**[0106]** In the example of FIG. **31**, as dielectric layers forming an electronic part, dielectric elements **22**A and **22**B are used in a stacked manner. A line **21**A is disposed on the top surface of a dielectric element **22**B, which is an upper layer, and a line **21**B is disposed in the slope. A GND surface **31** is sandwiched between the dielectric elements **22**A and **22**B.

**[0107]** In the example of FIG. **31**, the width of the line **21**B disposed in the slope of the dielectric element **22**B is set to a fixed width. By providing the GND surface **31** and by adjusting the thickness of the dielectric element **22**B in the slope on which the line **21**B is disposed, it is possible to set the width of the line **21**B to be fixed in the manner described above.

**[0108]** FIG. **32** is a sectional view of the structure shown in FIG. **31**.

**[0109]** As shown in FIG. **32**, the slope of the dielectric element **22**A has an angle that is the same as the slope of the dielectric element **22**B with respect to the substrate surface. The thickness of the dielectric element **22**B at each position of the line **21**B is adjusted using the GND surface **31** so that the thickness becomes fixed from the position  $P_{11}$  that is directly above the boundary between the top surface and the slope of the dielectric element **22**A up to the position  $P_{12}$  that is directly above the boundary between the top surface and the slope of the dielectric element **22**A. The thickness of the dielectric layer gradually decreases from the position  $P_{12}$  toward the connection part with the substrate.

**[0110]** As described above, it is also possible to set the number of dielectric layers on which a line is disposed to be plural. Furthermore, the present connection method can be applied to various cases in which two points having different heights are connected, for example, not only a case in which a line on an electronic part is connected to a line on a substrate on which the electronic part is mounted, but also a case in which a line on a substrate is connected to a line on another substrate.

**[0111]** FIG. **33** is a perspective view showing an example of a case in which the present connection method is used for the connection of a semiconductor package.

**[0112]** In the example of FIG. **33**, a semiconductor package **61** is mounted on a substrate **51**, and a chip part **62**, such as an LSI (Large Scale Integration) IC, is mounted thereon. Both the semiconductor package **61** and the chip part **62** have a shape in which the cross section thereof in the vertical direction is formed in the shape of a trapezoid. A plurality of electrodes **62**A are provided on the top surface of the chip part **62** in such a manner as to be exposed.

**[0113]** Wiring employing the present connection method can be applied to wiring **63** between a line disposed on the top surface of the chip part **62** from the electrode **62**A and a line on the top surface of the semiconductor package **61** and to wiring **64** between a line on the top surface of the semiconductor package **61** and a line on the substrate.

**[0114]** The present application contains subject matter related to those disclosed in Japanese Priority Patent Application JP 2008-156048 filed in the Japan Patent Office on Jun. 13, 2008 and Japanese Priority Patent Application JP 2008-214553 filed in the Japan Patent Office on Aug. 22, 2008, the entire content of which are hereby incorporated by reference. **[0115]** It should be understood by those skilled in the art that various modifications, combinations, sub-combinations and alterations may occur depending on design requirements and other factors insofar as they are within the scope of the appended claims or the equivalents hereof.

What is claimed is:

1. A connection method comprising the step of

connecting, using a line on a dielectric element, two points through which a signal flows, the two points having different heights and the widths of the line at the positions of the two points having been adjusted on the basis of the thickness of the dielectric element. **2**. The connection method according to claim **1**, wherein a higher point of the two points is a point on a line of an electronic part mounted on a substrate, and a lower point of the two points is a point on a line of the substrate.

**3**. The connection method according to claim **2**, wherein an area along which the thickness of the dielectric element decreases toward a connection part with the line of the substrate is formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights are connected by a line disposed along the area.

4. The connection method according to claim 2, wherein steps at which the thickness of the dielectric element decreases toward a connection part with a line of the substrate are formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights are connected by a line disposed on the steps.

**5**. A substrate, wherein two points through which a signal flows are connected using a line on a dielectric element, the two points having different heights and the widths of the line

at the positions of the two points having been adjusted on the basis of the thickness of the dielectric element.

6. The substrate according to claim 5, wherein a higher point of the two points is a point on a line of an electronic part mounted on a substrate, and a lower point of the two points is a point on a line of the substrate.

7. The substrate according to claim 6, wherein an area along which the thickness of the dielectric element decreases toward a connection part with the line of the substrate is formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights are connected by a line disposed along the area.

8. The substrate according to claim 6, wherein steps at which the thickness of the dielectric decreases toward a connection part with the line of the substrate are formed in the end portion of the electronic part composed of a dielectric material, and the two points having different heights are connected by a line disposed on the steps.

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